



Testing Methods for Verification of a Mounted Accelerometer Frequency Response

Dr. Th. Petzsche - Kistler Instrumente GmbH



Testing Methods for Verification of a Mounted Accelerometer Frequency Response

Dr. Th. Petzsche - Kistler Instrumente GmbH

Goal

- Mounted resonance frequency (MRF)
 - Part of specification in the data sheet of any accelerometer beside the damping coefficient (DmpCo), given for stiffest mounting
 - Expresses usually the frequency response of an accelerometer as key parameter, beside damping coefficient, mechanical quality of resonance, HP- & LP- filter frequency
 - Parameter function to combine sensitivity of the sensor over frequency

- MRF measurement represents (ISO16032-32:2016, ISO5347-14, ISA-RP37.2)
 - Quality of mounting (influenced by scratches, roughness, stiffness, ...)
 - Provides hints on the mounting conditions
 - Ratio of masses between 'Structure under Test' and 'Sensor'
 - Sensor functionality at all

- Goal
 - Understanding of MRF in boundary conditions as depending:
 - (1) Sensor mounted to a large mass
 - (2) Sensor suspended in air, not mounted
 - Overview of different procedures to determine MRF, inverse and direct piezoelectric
 - **Does the results correlate with theory? What can we learn about mounting ?**

Conclusions to MRF

depending from the boundary conditions

(1) Non-fixed two mass spring system

$$\omega_0 = \sqrt{k \cdot \left(\frac{1}{m_1} + \frac{1}{m_2} \right)} \quad k = \frac{k_1 \cdot k_2}{k_1 + k_2}$$

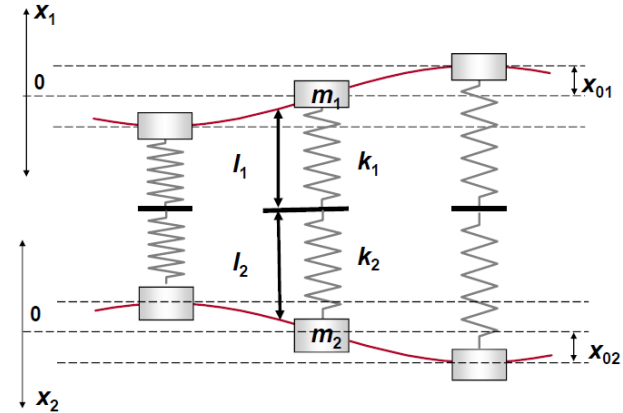
where spring constant k is formed by the two k_1 and k_2 in series

(2) Fixed one mass spring system

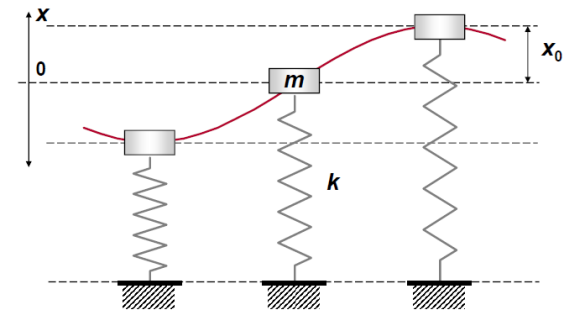
$$\omega = \sqrt{\frac{k}{m}} = \sqrt{\frac{E \cdot A}{l \cdot m}}$$

▪ For (1) $m=m_1=m_2$: $\omega_0 = \sqrt{2} \omega$.

$$\omega_0 > \omega.$$



1. Non-fixed two mass spring system



2. Fixed one mass spring system

An Accelerometer under...

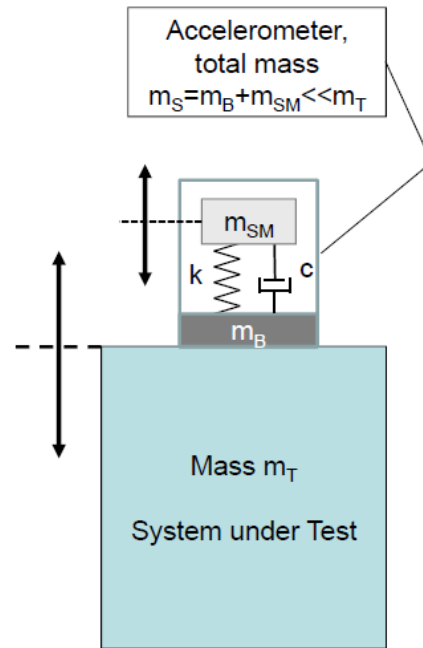
mounted and loose boundary conditions

- Left - Case 1: Typical Vibration Testing configuration, Accelerometer mass

$$m_S = m_B + m_{SM}$$

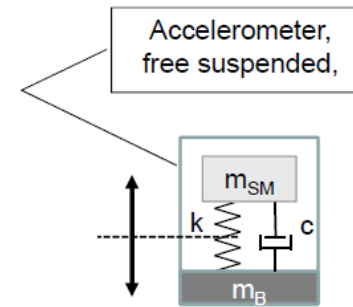
- Mass system under test

$$m_T \gg m_S$$



- Right - Case 2: Sensor free suspended in air,

$$m_S = m_B + m_{SM}$$



- The natural frequency in the mounted state f_m Case 1 is given by:

$$f_m = \frac{1}{2\pi} \sqrt{\frac{k}{m_{SM}}}$$

- Case 2 is given by:

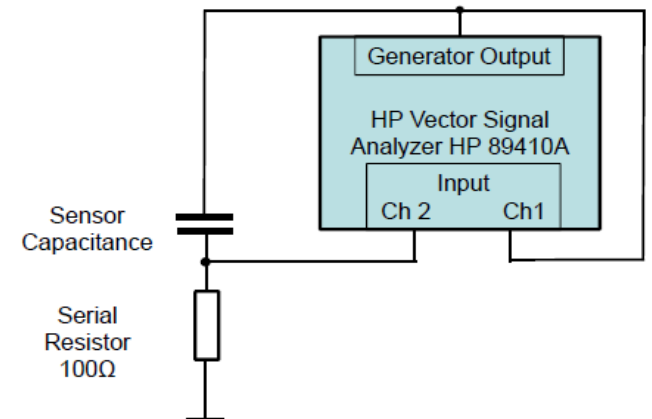
$$f_s = \frac{1}{2\pi} \sqrt{k \left(\frac{1}{m_B} + \frac{1}{m_{SM}} \right)}$$

- The mass of piezoelectric elements and its fixing tools has been neglected.

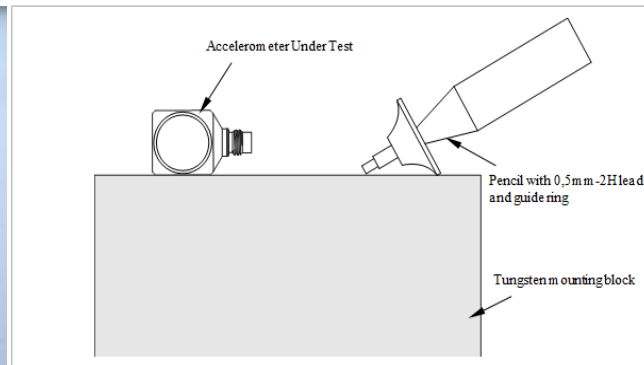
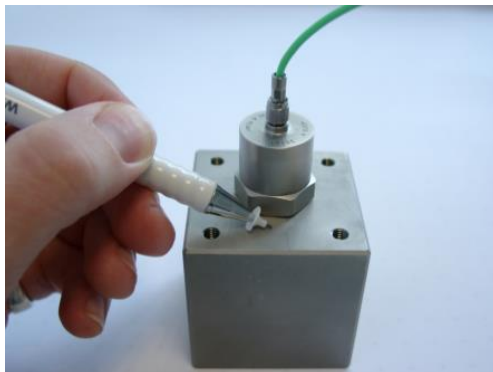
- For these two boundary conditions – test of MRF's
- Investigation using different excitation methods to excite the seismic mass using the **inverse piezoelectric effect** thanks to an alternating voltage applied to the capacitance of the sensor.
- Per standard definitions, the resonance frequency is achieved at the lowest frequency where the sensor reaches its maximum sensitivity while excited with an external vibration.
- Accelerometer under test:

KISTLER Type:	8203A50	8202A10
Minimal mounted resonance frequency belong to data sheet	>24 kHz	>45 kHz
Sensitivity at 100 Hz	50 pC/g	10 pC/g
Principle	Ceramic shear	
Capacitance	1400 pF	500 pF
Total sensor mass	44,5 g	14,5 g
Total Mass of seismic element	13,06 g	2,335
Total mass of sensor without pe element and seismic mass	30,62 g	11,813 g

- Different methods to determine the accelerometer resonance frequency
- **Inverse piezoelectric** resonance excitation of an accelerometer with the
 - (1) Vector Analyzer Technology (HP 89410 (DC to 10 MHz), transfer fct.
 - (2) with a single electric pulse, FFT transfer fct.
 - (3) Random noise test, FFT transfer fct.
- **Direct piezoelectric** excitation with a
 - (4) short mechanical pulse (HSU-Nielson pencil test)
 - (5) Swept sine shaker test, sinusoidal excitation



(1): Method Vector Analyzer.
Sensor in series with resistor

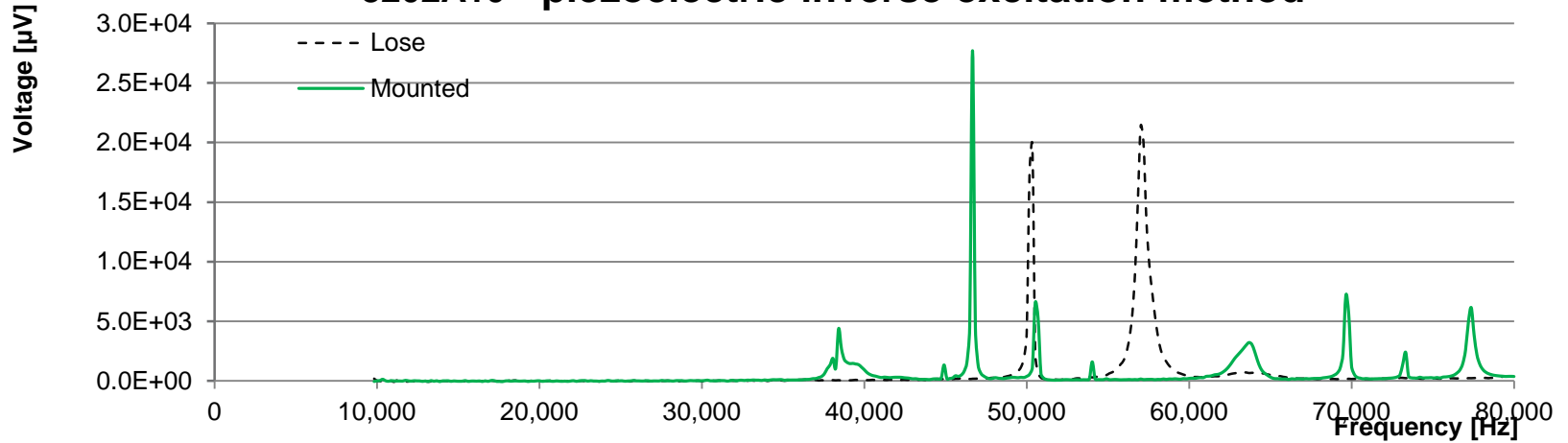


(4) Pencil lead break on a steel cube of $25,4 \text{ mm}^3$ (similar to the HSU-Nielson source for acoustic emission testing)

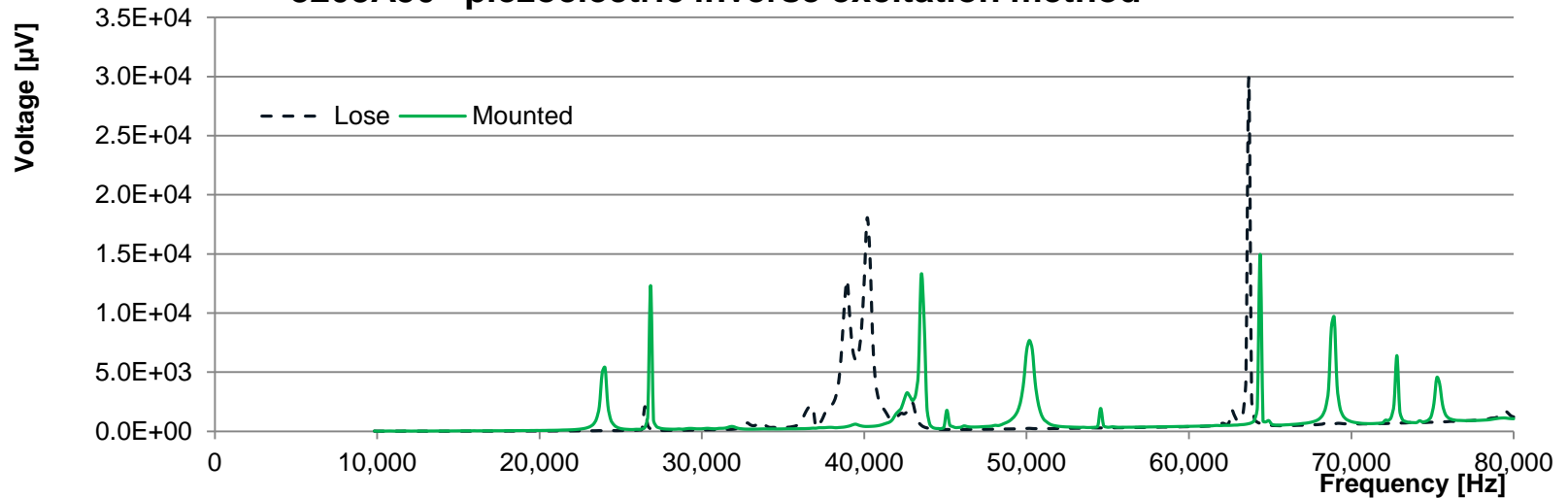
Results with Method (1) , Resonance Search

Vector Analyzer Method

8202A10 - piezoelectric inverse excitation method



8203A50 - piezoelectric inverse excitation method



Vector Analyzer Method

- Hanging and mounted resonances for sensors type 8203A50 and 8202A10.
 (It means: $1/m = 1/m_1 + 1/m_2$; $m_1 = m_s - (m_{PE} + m_2)$;
 mass of the piezoelectric element and its fixing m_{PE}).

Sensor Type	Mass of seismic mass m_2	Total Mass of sensor m_s	Mass of Sensor - seis. Mass & PE element) m_1	Reduced mass m	Measured res. freq., hanging f_{res_loose}	Calculated spring const. k	Calculated mounted res. freq. f_{res_mount}	Measured mounted res. freq., f_{res_mount}	
	g	g	g	g	Hz	N/m	Hz	Hz	Hz
								1 st mode	2 nd mode
8203A50	13,06	44,5	30,62	9,155	26316	250287758	22033	23850	26842
8202A10	2,335	14,5	11,81	1,949	50350	195112505	46007	38421	46666

- Comparison of calculated MRF with spring constant calculated from the 'Not mounted loose' data and measured MRF
- Good correlation of results, uncertainties by not individually known masses (like pe element, ...)

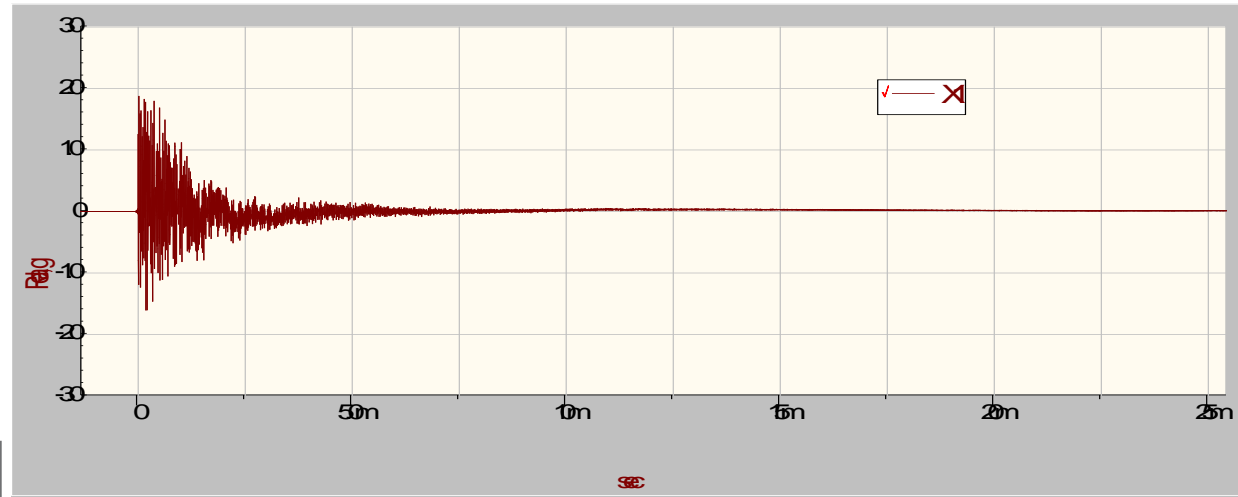
Method (4), HSU-Nielson Test

Direct Piezoelectric Generated Signal

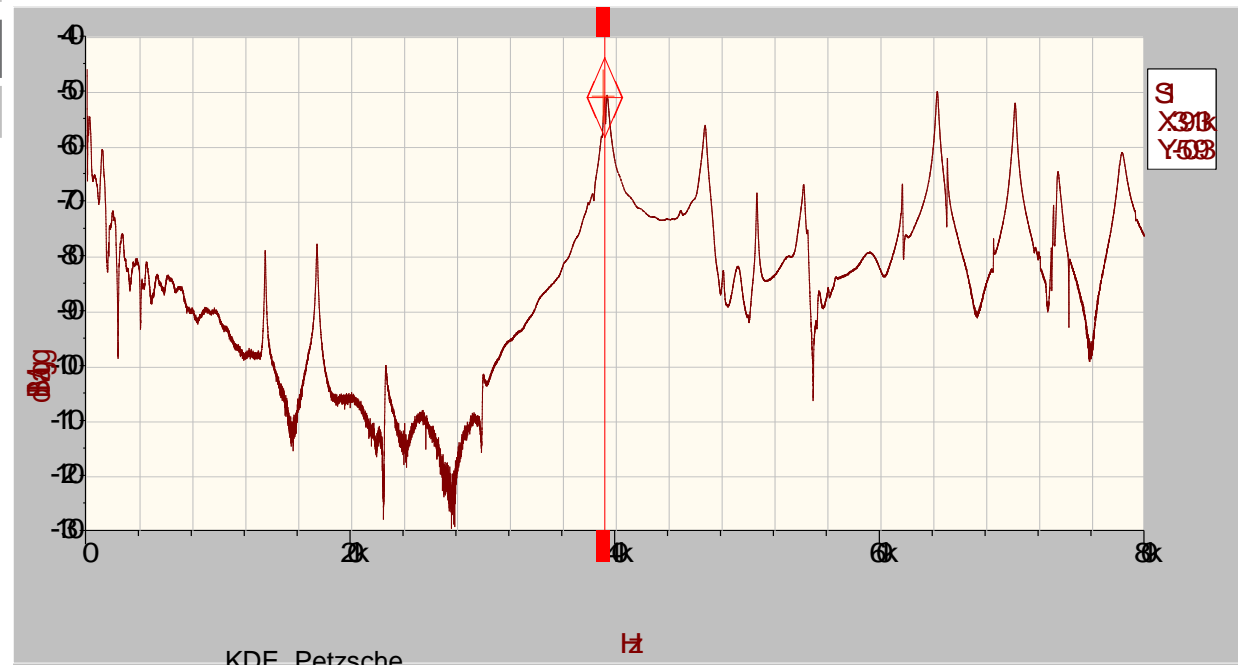
- FFT Auto Power Spectrum from the time signal for the sensor 8202A10
- Sensor resonances at:

1	2	3	4
39,13 kHz	46,70 kHz	50,62 kHz	54,16 kHz
5	6	7	8
61,62 kHz	64,23 kHz	70,11 kHz	73,37 kHz
9			
78,21 kHz			

X1



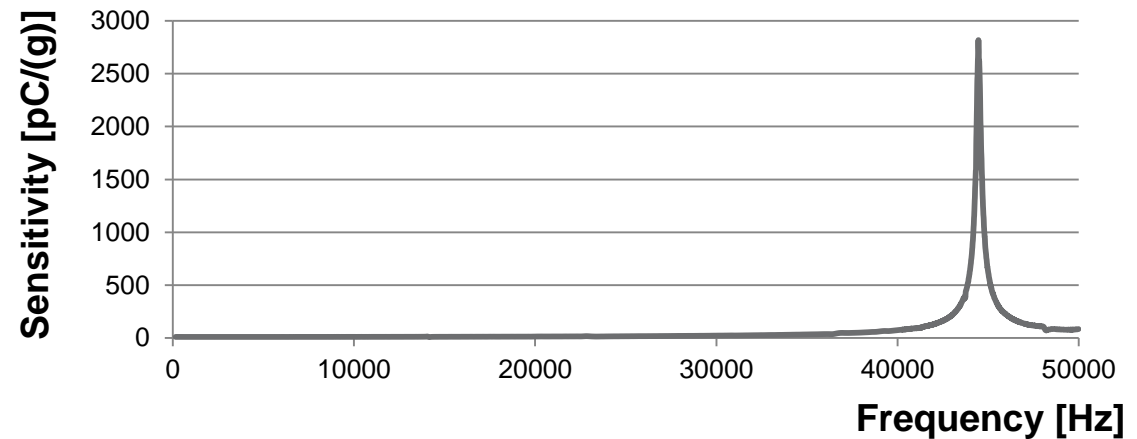
S1



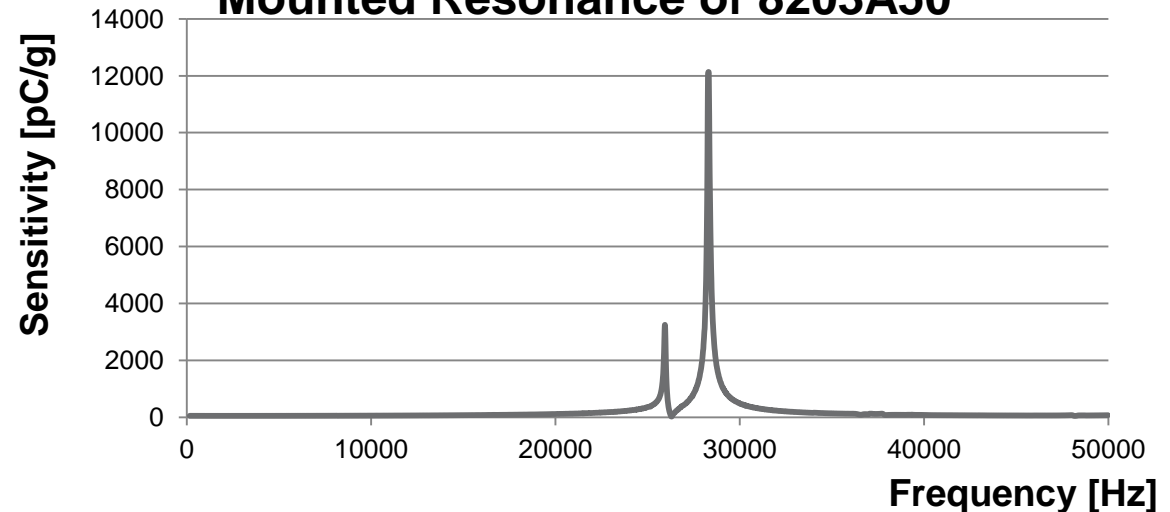
- Shaker: Spektra SE-09, 1 kHz up to 50 kHz
- Resonance search with tight frequency steps, min. 1600 points
- Results:
8202A10
 $f_{\text{res}} = 44,47 \text{ kHz}; 48 \text{ dB}$

8203A50
 $f_{\text{res1}} = 25,93 \text{ kHz}; 35 \text{ dB}$
 $f_{\text{res2}} = 28,32 \text{ kHz}; 48 \text{ dB}$

Mounted Resonance of 8202A10



Mounted Resonance of 8203A50



Summary of Results - 1

Excitation	Inverse Piezoelectric				Piezoelectric				
	Vector Signal Analyzer (1)				Impuls (2) White Noise (3)	HSU-Nielson (4)		Swept Sine Test (5)	
Sensor Type	Measured res. freq., loose $f_{res, loose}$	Calculate d MRF $f_{res, mount.}$	Measured MRF $f_{res, mount.}$		Measured MRF $f_{res, mount.}$	Measured MRF $f_{res, mount.}$		Measured MRF $f_{res, mount.}$	
	Hz	Hz	Hz	Hz	Hz	Hz	Hz	Hz	Hz
			1 st mode	2 nd mode	2 nd mode			1 st	2 nd
8203A50	26316	22033	23850	26842	27730 27040	24930	27090	25120 25930	28180 28321
8202A10	50350	46007	38421	46666	46670 46680	39130	46700	36226 (weak)	44670 44465

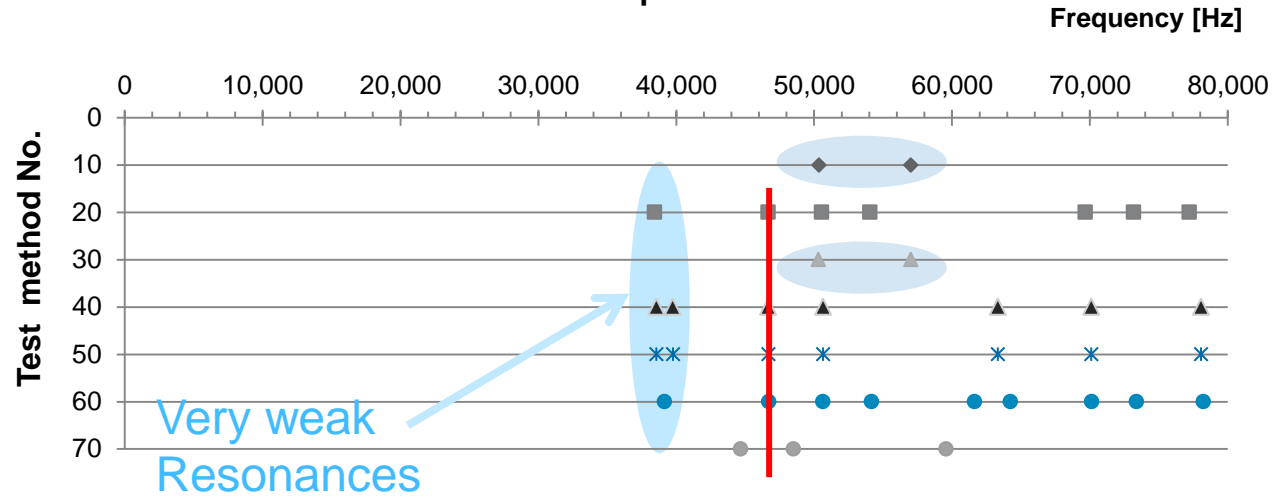
INTERPRETATION

- Impressive consistency within loose and mounted results
- Inverse PE: Excitation of all possible resonances (length, shear, thickness and more)
- Less excited modes for direct piezoelectric excitation
- Slightly different mounting conditions influences results

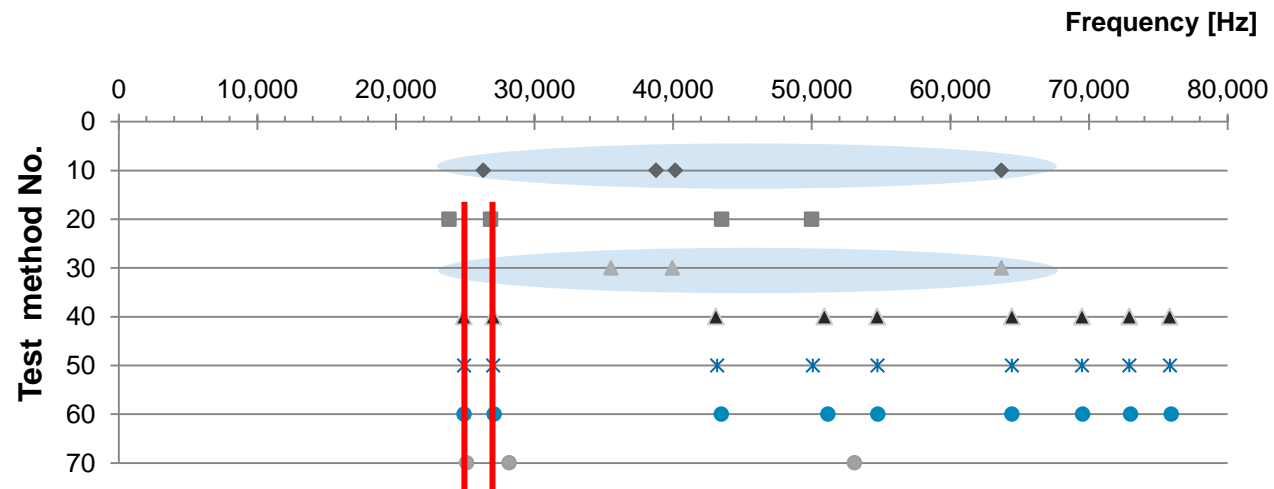
Summary of Results-2, Method (1)-(5)

Test method No.	Sensor	Test description
10	loose	Vector Signal Analyzer
20	mount.	Vector Signal Analyzer
30	loose	Single electrical pulse, transfer fct.
40	mount.	Single electrical pulse, transfer fct.
50	mount.	Random noise test, transfer fct.
60	mount.	HSU-Nielson test (pencil lead), transfer fct.
70	mount.	Shaker test, sinusoidal excitation

Resonance Frequencies for 8202A10



Resonance Frequencies for 8203A50



Conclusions:

What do we see in our daily routine? What can we learn ?

■ Configuration 1

Fixed to UUT with large mass

■ Configuration 2

Not mounted, suspended in air

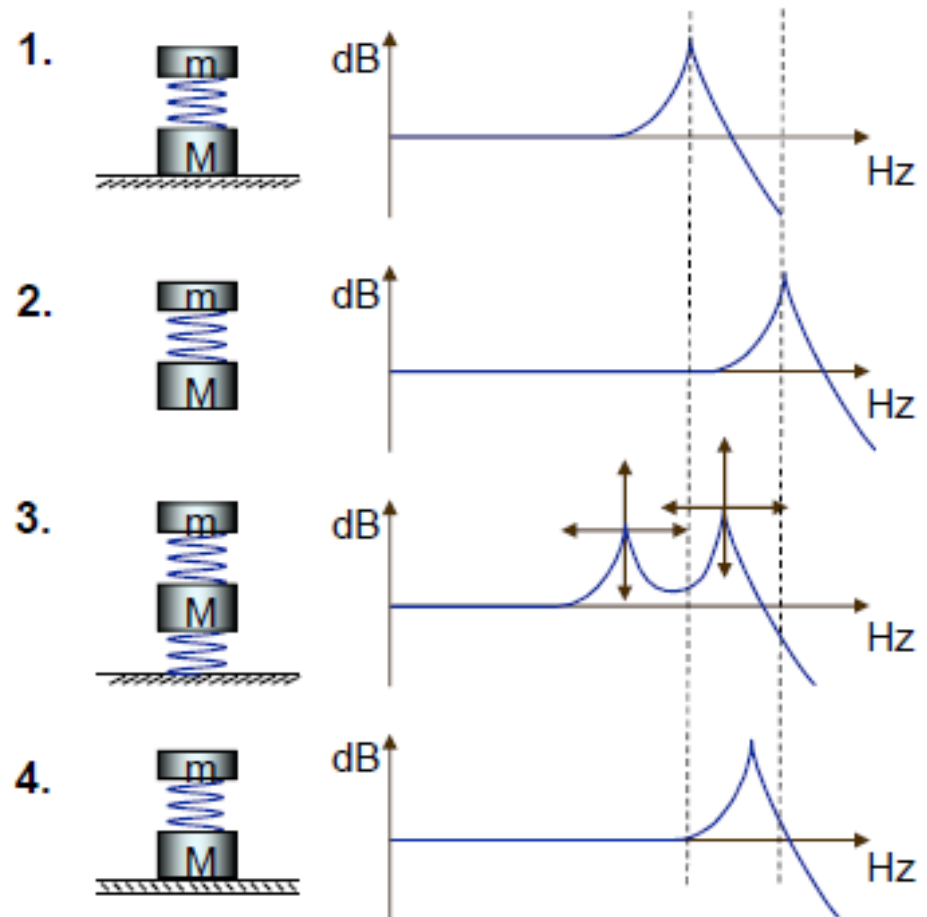
■ Configuration 3

Soft mounted, loose mounted, scratches, lower mounting torque c high roughness of the mounting area,

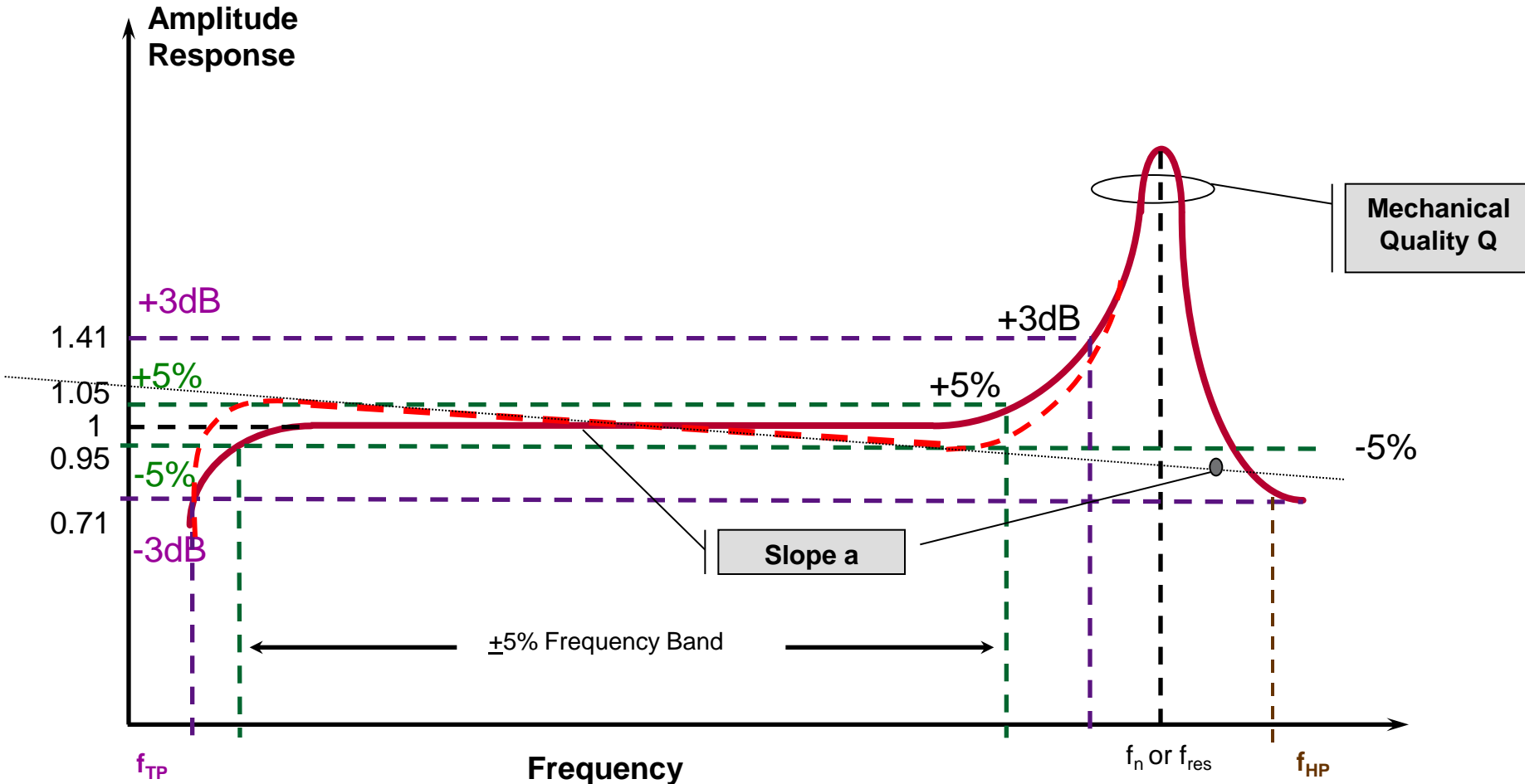
■ Configuration 4

Mounted to a lightweight structure
→ inclusive possible mass loading effects

- → Influences directly MRF !
20% of MRF sensitivity change
±5% (weak damping)



FFT Frequency Response Correction with Accelerometer Frequency Response



Accelerometer Transfer Function, used in TEDS Template 25

$$S(f) := \hat{I}_c \text{ (Sign)} \cdot S_{\text{ref}} \left[1 + b \cdot (T - T_{\text{ref}}) \right] \cdot \frac{\frac{j \cdot f}{f_{\text{hp}}} \cdot \left(\frac{j \cdot f}{f_{\text{ref}}} \right)^{\frac{a}{\ln(10)}}}{\left(1 + \frac{j \cdot f}{f_{\text{hp}}} \right) \cdot \left(1 + \frac{j \cdot f}{f_{\text{lp}}} \right) \cdot \left[1 + \left(\frac{j \cdot f}{f_{\text{res}}} \right)^2 + \frac{j \cdot f}{Q \cdot f_{\text{res}}} \right]}$$

Summary of Parameter

Sign, References

\hat{I}_c - sensitivity direction

Sign – polarity

S_{ref} - reference sensitivity

Temperature Response

b - temperature coefficient

T - temperature

T_{ref} - reference temperature

Frequency Response

f - frequency

f_{hp} - high-pass cut off frequency

f_{lp} - low-pass cut off frequency

f_{res} - resonance frequency

f_{ref} - reference frequency

Q - Quality factor

a - amplitude slope / decade